



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Bencher et al.

Patent No.: 6,951,826

Issued:

October 4, 2005

Serial No.: 10/684,079

Filed:

October 9, 2003

For:

SILICON CARBIDE

DEPOSITION FOR USE AS A LOW DIELECTRIC

CONSTANT ANTI-

REFLECTIVE COATING

Certificate of Correction Branch Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2891

Examiner:

Victor V. Yevsikov

CERTIFICATE OF MAILING

37 CFR 1.8

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Signature

REQUEST FOR CERTIFICATE OF CORRECTION

Attached is a Certificate of Correction for correcting several errors in the specification of the printed patent.

Applicants submit that the errors mentioned above were not made by the applicants, but were made during the printing of the patent.

Respectfully submitted,

JUN Certificate

of Correction

Keith M. Tackett

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(Also Form PTO-1050)

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO.: 6,951,826

Page 1 of 1

APPLICATION NO.: 10/684,079

DATED: Oct. 4, 2005

INVENTOR(S): Christopher BENCHER, Joe FENG, Mei-Yee SHEK, Chris NGAI, Judy HUANG

It is certified that error appears in the above-identified patent and that said Letters Patent are hereby corrected as shown below:

In the Specification

Column 2, Line 58: Change the second and third instances of "k" to --κ--

Column 9, Line 7: Change "(HSi(CH₃)-Si(CH₃)₂H)" to --(HSi(CH₃)₂-Si(CH₃)₂H)--

Column 9, Line 9: Change "(H(CH₃)₂Si—Si(CH₃)SiH(CH₃)₂)" to --(H(CH₃)₂Si—Si(CH₃)₂---SiH(CH₃)₂)--

Column 10, Line 38: Change "2000" to --200°--

Column 11, Line 4: Change "Sic" to --SiC--

Column 11, Line 18: Change "k" to -- k--

Column 14, Line 1: Change "ic" to -- k--

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